

## The most flexible HiPIMS pulser for R&D departments and academia



## **HiPSTER 1 HiPIMS Pulser**

The HiPSTER unit is designed by expert users in the field of thin film deposition in order to generate a robust and repeatable HiPIMS process, also in reactive mode. This means stable operation with constant voltage throughout the whole discharge pulse without any unwanted oscillations.

With new ultra-fast switching technology the HiPSTER will be the perfect tool when developing and running state-of-theart HiPIMS processes. Also, upgrading your existing magnetron system to HiPIMS has never been easier: The HiPSTER can be directly fitted to existing DC power supplies. This is also a cost-efficient way to true HiPIMS.

## **Features**

- + Stable and robust discharge process (constant voltage and no unwanted oscillations)
- + Can be triggered externally (multiple power supplies)
- New switching technology allowing HiPIMS pulsing frequencies up to 10 kHz
- + Tested using a wide range of magnetrons and processes (incl. reactive HiPIMS)
- + Unique feedback system allowing process regulation by controlling the pulse current
- + Real-time information on the discharge pulse voltage and current
- Add Ionautics' superposition technology for HiPIMS + DC

## **Applications**

- Hard coatings: Smoother and denser elemental as well as reactively deposited compound coatings, which result in increased hardness, reduced corrosion, and less friction
- + Optical coatings: Increased optical properties through smoother interfaces and denser structures
- + Diffusion barriers: Better performance through increased coating density
- Electrical coatings: Improved conductivity enabling reduced coating thickness and reduced heat load.
  Also increased isolation in the case of insulators can be obtained
- + 3-D coatings: Uniform film coverage on complex shaped substrates







Output Specifications	
Output Average Power:	≤ 1000 W
Output Peak Voltage:	≤ 1000 V
Output Peak Current:	≤ 100 A
Regulation Modes:	Voltage, Current,
	Power, Pulse current
Pulse Frequency:	1 to 10 000 Hz
Pulse Duration:	2.5 μs to 1000 μs
Arc control: reaction time	< 2 µs

Input Specifications	
Input Voltage AC:	1 phase + N, 100-240 VAC, 50/60 Hz
Input Current at 230 V:	0.3 A
DC Charging Input:	1000 V max, positive grounded
Trigger In:	Ground-Referenced 5V CMOS input

Dimensions	
Size:	19" rack (3U)
	135 mm (H) x 483 mm (W) x 390 mm (D)
Weight:	5 kg



Environmental Specifications	
Operating Temperature:	+5°C to + 40°C
Storage Temperature:	-25°C to +55°C
Relative Humidity:	max 85% non-condensing
Air Pressure:	80 kPa to 106 kPa
Cooling:	Air Cooling
Pollution degree:	2 (or better). Cooling air must normally be free of corrosive vapors and conductive particles.
Norms:	CE marked

